

CORRIGENDUM

No. IITMANDI/S&P/PUR- 172/2016-17/8409-10

Date: 07.12.2016

To

1. Institute Website IIT Mandi
2. Central Public Procurement Portal.

Sub:- Corrigendum to NIT No. IITMANDI/S&P/PUR- 172/2016-17/7624-25 dated 15th November, 2016 for Compact Reactive Ion Etching (RIE) System.

The Last date for submission of Tender has been extended from **07th December, 2016 to 22th December, 2016 till 01:00 P.M.** as the CPP Portal was down due to some maintenance issue.

Date for **Technical Bid opening** has been extended from **07th December, 2016 to 22th December, 2016 at 3:00 PM.** For any technical queries & clarification regarding the tender, the bidders are requested to contact our office through e-mail: satinder@iitmandi.ac.in.

Those who have already sent their bids need not bid again, and their earlier bids will be considered.

All other terms and conditions remain the same.

Sd/-
**Assistant Registrar
(Stores & Purchase)**